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UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Group Art Unit: **3663**

Application Number: **10/743,793**

Examiner: **Johannes P. Mondt**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **SEMICONDUCTOR SUBSTRATE AND MANUFACTURING
METHOD THEREOF**

Attorney Docket Number: **032206**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

May 3, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated January 4, 2006 for one month from April 4, 2006 to May 4, 2006.

Attached please find a check in the amount of \$120.00 for the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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